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Attorney Docket No.: SAM-0465
Application Serial No.: 10/685,738
Reply to Office Action of: September 14, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.* Examiner: Chen, Kin Chan
Serial No.: 10/685,738 Group Art Unit: 1765
Filing Date: October 15, 2003
Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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AMENDMENT AFTER FINAL

Sir:

KCC
11/18/05

The following is in response to the Office Action dated September 14, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.